

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Not for submission under 37 CFR 1.99)

Application Number 10779373

Filing Date 2004-02-17

First Named Inventor SCHAEPKENS, et al.

Art Unit 1794

Examiner Name Kevin R. Kruer

Attorney Docket Number GER01 006

U.S. PATENTS

Examiner Initial*	Cite No	Patent Number	Kind Code1	Issue Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
	1	6777871	B2	2004-08-17	Duggal et al.	
	2	6642652	B2	2003-11-04	Collins, III et al.	
	3	6576351	B2	2003-06-10	Silvermail	
	4	6522067	B1	2003-02-18	Graff et al.	
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	8	6097147	A	2000-08-01	Baldo et al.	

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9	6023371	A	2000-02-08	Onitsuka et al.	
10	5998803	A	1999-12-07	Forrest et al.	
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FOREIGN PATENT DOCUMENTS

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	1	0026973	WO	A1	2000-05-11	Delta V Technologies, Inc.		<input type="checkbox"/>
	2	0181649	WO	A1	2001-11-01	Battelle Memorial Institute		<input type="checkbox"/>
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Examiner Initials*	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.	T ⁵
	1	H. SUZUKI et al., Near-Ultraviolet Electroluminescence from Polysilanes, 331, Thin Solid Films, p. 64-70, 1998.	<input type="checkbox"/>

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